

SON-2043

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of )

Shuzo SATO et al. )

Serial No. To be assigned )

Filed: March 8, 2001 )

For: METHODS OF PRODUCING AND )  
POLISHING SEMICONDUCTOR DEVICE )  
AND POLISHING APPARATUS )

ATT: APPLICATION BRANCH

5A  
OK  
7/24/01

PRELIMINARY AMENDMENT ACCOMPANYING FILING

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Prior to the initial examination, please amend the above-identified application as follows:

IN THE SPECIFICATION:

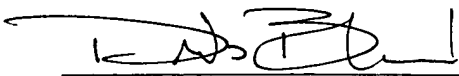
Page 32, line 3, change "Fig. 22" to -- Fig 22A and Fig 22B--

REMARKS

This Preliminary Amendment is requested to accurately identify the drawings. No new matter has been added. Entry of this amendment is requested.

Respectfully submitted,

Date: March 8, 2001

 42,314

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